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Attorney Docket SEL 147-CON

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )

Hisashi OHTANI )

Serial No.: 09/916,913 )

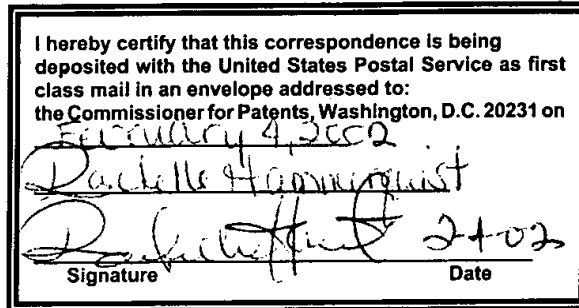
Filed: July 27, 2001 )

For: Method Of Manufacturing )  
Thin Film Transistor )

Art Unit: 2823 )

Examiner: D. Collins )

Commissioner for Patents  
Washington, D.C. 20231



**ELECTION AND AMENDMENT A**

Sir:

In response to the Restriction Requirement of January 2, 2002, the one month deadline falling on a Saturday and this response being filed on the Monday thereafter, Applicant elects to prosecute Group I: Claims 4-6 drawn to an active matrix substrate in the above-identified application. Applicant is making this election without prejudice to later filing a divisional application on the non-elected claims.

Please also amend the above-identified application as follows:

**IN THE CLAIMS:**

Cancel Claims 1-3 and 7-11.

04/25/2002 09:00:01 00000004 501039 099113  
72.00 CH  
232.00 CH